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JUL 16 2004

MI22-1544

Application Serial No. 09/677,478
Response to March 16, 2004 OA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/677,478
Filing Date October 2, 2000
Inventor Guy T. Blalock
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Lan Vinh
Attorney's Docket No. MI22-1544
Title: Plasma Etching Methods

RESPONSE TO MARCH 16, 2004 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
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Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

file processed

Responsive to the Office Action dated March 16, 2004, Applicant
amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

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